

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Shi-Chang Wooh

Serial No:

09/898,815

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Uga hadrsh Olga Kadish

RESPONSE

This Response is in reply to the Final Office Action mailed May 19, 2003 in the subject application. In response to the Office Action, please amend the above-identified application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.